

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

FARHAD K. MOGHADAM et al.

Application No.: 10/627,228

Filed: July 25, 2003

For: SEQUENTIAL GAS FLOW OXIDE
DEPOSITION TECHNIQUE

Customer No.: 57385

Confirmation No. 2446

Examiner: Rodney Glenn McDonald

Technology Center/Art Unit: 1795

AMENDMENT AFTER ALLOWANCE
UNDER 37 CFR § 1.312

Mail Stop Issue Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Supplemental Notice of Allowance mailed March 25, 2008,
please amend the above-identified application as follows:

Remarks/Arguments begin on page 2 of this paper.